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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

First Named Inventor:	Il-Joo Cho, et al	§	
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Conf. No.:		§	Group Art Unit: To be assigned
		§	
Appln. No.:	To be assigned	§	Examiner: To be assigned
		§	
Filing Date:	February 12, 2004	§	Attorney Docket No.: 10061-17U1 (P02000-11US/DV)
		§	
Title:	METHOD OF FABRICATING PROBE FOR SCANNING PROBE MICROSCOPE		

**INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. §1.97(b)**

Enclosed are copies of each of the documents listed on the attached Information Disclosure Citation Form(s) PTO/SB/08A, which may be material to the patentability of this application and/or for which there may be a duty to disclose in accordance with 37 C.F.R. §1.56.

The filing of this Information Disclosure Statement shall not be construed as an admission that any of the listed documents constitutes prior art, nor as an admission against interest in any manner. The cited references were cited by Applicant and/or the Examiner in parent application 09/598,656, and the U.S. patent references are therefore not being provided again. However, a copy of the Tortonese et al. article is provided for the Examiner's convenience.

No fee is believed to be due in connection with the filing of this Information Disclosure Statement since it is being filed within three months of the filing date of the above-identified application. However, the Commissioner is hereby authorized to charge any deficiencies or credit any overpayments to Deposit Account No. 50-1017.

It is respectfully requested that this Information Disclosure Statement and the documents listed on the attached Form PTO/SB/08A be considered and acknowledged by the Examiner in connection with the above-identified patent application, be made of record therein, and that the listed document(s) be cited in the issued patent.

Respectfully submitted,

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WWS:rc  
Enclosures

Form PTO/SB/08A				<b>Complete if Known</b>	
<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>  (use as many sheets as necessary)				<b>Application Number</b>	To be assigned
				<b>Filing Date</b>	February 12, 2004
				<b>First Named Inventor</b>	Il-Joo Cho, et al
				<b>Group Art Unit</b>	To be assigned
				<b>Examiner Name</b>	To be assigned
Sheet	1	of	1	<b>Attorney Docket Number</b>	10061-17U1 (P02000-11US/DV)

U.S. PATENT DOCUMENTS				
Exr Initials	U.S. Patent Document		Name of First Inventor of Cited Document	Date of Publication of Cited Document MM-YYYY
	Number	Kind Code (if known)		
	4,943,719		Akamine et al.	07-1990
	4,968,585		Albrecht et al.	11-1990
	5,021,364		Akamine et al.	06-1991
	5,475,318		Marcus et al.	12-1995
	5,489,774		Akamine et al.	02-1996
	5,856,967		Mamin et al.	01-1999

FOREIGN PATENT DOCUMENTS						
Exr Initials	Foreign Patent Document			Name of Applicant of Cited Document	Date of Publication of Cited Document MM-YYYY	T <sub>1</sub>
	Country Code	Number	Kind Code (if known)			

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS		
Exr Initials	Include Name of first Author (in CAPITAL LETTERS), title of the article (where appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), volume-issue number(s), page(s), date (in parentheses). If a book, also include publisher and city and/or county where published.	T <sub>1</sub>
	TORTONESE, M. et al. "Atomic Force Microscopy Using a Piezoresistive Cantilever", C.F. Quate et al., <i>Solid State Sensors and Actuators</i> , pp. 448-451, (1991).	

Examiner Signature		Date Considered	
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